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**PATENT**

Docket No.: 50195-257

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : **RESPONSE UNDER 37 C.F.R. 1.116**  
: **EXPEDITED PROCEDURE**  
:   
Norihiro KIRITANI : Confirmation No. 7093  
: Customer No. 20277  
:   
Application No.: 09/817,154 : Group Art Unit: 2823  
: Examiner F. Toledo  
:   
Filed: March 27, 2001 :   
:   
For: METHOD FOR MANUFACTURING SILICON CARBIDE DEVICE AND OXIDATION  
FURNACE

**AMENDMENT and REQUEST FOR RECONSIDERATION**  
**UNDER 37 CFR § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This is a response to the final Office Action dated May 16, 2003. The above-identified patent application has been amended as set forth below.

Claims 1, 9, 13 and 15-17 have been amended. A listing of all claims presented in the present application is presented in the "Amendments to the Claims" beginning at page 2 of this response.